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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/734,711	12/12/2003	Ric Kojima	10873.659USDI	2337
7590 06/13/2007 Hamre, Schumann, Mueller & Larson, P.C. P.O. Box 2902-0902 Minneapolis, MN 55402			EXAMINER MCDONALD, RODNEY GLENN	
		ART UNIT 1753	PAPER NUMBER	
		MAIL DATE 06/13/2007	DELIVERY MODE PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Office Action Summary	Application No.	Applicant(s)	
	10/734,711	KOJIMA ET AL.	
Examiner	Art Unit		
Rodney G. McDonald	1753		

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

1) Responsive to communication(s) filed on 29 May 2007.

2a) This action is **FINAL**. 2b) This action is non-final.

~3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

4) Claim(s) 11-15 is/are pending in the application.
4a) Of the above claim(s) _____ is/are withdrawn from consideration.

5) Claim(s) _____ is/are allowed.

6) Claim(s) 11-15 is/are rejected.

7) Claim(s) _____ is/are objected to.

8) Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

9) The specification is objected to by the Examiner.

10) The drawing(s) filed on _____ is/are: a) accepted or b) objected to by the Examiner.

Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).

Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).

11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
a) All b) Some * c) None of:
1. Certified copies of the priority documents have been received.
2. Certified copies of the priority documents have been received in Application No. _____.
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a))

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

1) Notice of References Cited (PTO-892) 4) Interview Summary (PTO-413)
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) Paper No(s)/Mail Date. ____ .
3) Information Disclosure Statement(s) (PTO/SB/08)
Paper No(s)/Mail Date. ____ .
5) Notice of Informal Patent Application
6) Other: ____ .

DETAILED ACTION

PROSECUTION REOPENED

Prosecution is reopened in view of the newly discovered reference(s) to deNeufville et al. (U.S. Pat. 4,621,032). Rejections based on the newly cited reference(s) follow.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 11, 12 and 15 are rejected under 35 U.S.C. 103(a) as being unpatentable over deNeufville et al. (U.S. Pat. 4,621,032).

Regarding claim 11, deNeufville et al. teach a method of manufacturing an information recording medium including a substrate and a recording layer disposed

above the substrate. (See Abstract) The recording layer comprises constituent elements Ge, Sb, Te, Sn and at least one element M selected from Al and N. The recording material is phase reversible between a crystal phase and an amorphous phase by an irradiation of an energy beam. (Column 4 lines 30-61)

Regarding claim 12, the vapor deposition method can include evaporation. (Column 4 lines 62-68; Column 5 lines 1-7)

Regarding claim 15, the recording layer can be 5 nm to 200 nm. (Column 5 lines 61-63)

The differences between deNeufville et al. and the present claims is that the composition formula of the recording layer is not discussed (Claim 11).

Regarding claim 11, since deNeufville et al. teach that the recording layer can comprise mixtures of Te, Ge, Sn, Sb, N, Al this suggests the composition of Applicant's claims. (Column 4 lines 38-61)

The motivation for utilizing the features of deNeufville et al. is that it allows for making an optical storage device. (See Abstract)

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have utilized the features of deNeufville et al. because it allows for forming an optical storage device.

Claim 13 is rejected under 35 U.S.C. 103(a) as being unpatentable over deNeufville et al. as applied to claims 11, 12 and 15 above, and further in view of Kikukawa et al. (U.S. Pat. 6,329,036).

The differences not yet discussed is utilizing a sputtering method is not discussed (Claim 13), using during sputtering a gas comprising at least one gas selected from nitrogen gas and oxygen gas and one rare gas selected from argon and krypton (Claim 13).

Regarding claim 13, Kikukawa et al. teach a method of manufacturing an information recording medium including a substrate and recording layer disposed above the substrate. The method comprises a vapor deposition method such as sputtering. The recording layer comprises Ag, In, Sb and Te as main components and Ge or nitrogen (N). The nitrogen is incorporated into the recording layer by sputtering in an atmosphere containing nitrogen gas in addition to a rare gas such as argon. The recording layer is a phase reversible recording layer, which changes between a crystal phase and amorphous phase by irradiation from a laser beam (Fig. 1; Column 4 lines 57-61; Column 4 lines 48-51; Column 10 lines 8-15; Column 12 lines 51-64)

Regarding claim 13, Kikukawa et al. teach utilizing nitrogen and argon for the sputtering. (Column 10 lines 8-15)

The motivation for utilizing the features of Kikukawa et al. is that it allows for forming a recording medium. (See Abstract)

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have utilized the features of Kikukawa et al. because it allows for forming a recording medium.

Claim 14 is rejected under 35 U.S.C. 103(a) as being unpatentable over deNeufville et al. in view of Kikukawa et al. as applied to claim 11-13 and 15 above, and further in view of Ohno et al. (U.S. Pat. 6,033,535).

The difference not yet discussed is that the deposition rate is not discussed.

(Claim 14)

Regarding claim 14, Ohno et al. teach that the deposition rate can be controlled depending on the substrate shape, Target Substrate distance, target shape, and so on. (Column 8 lines 48-52) Therefore the deposition rate is a result effective variable and Applicant's deposition rate can be achieved given that sputtering and the same materials for sputtering are being utilized by Ohno et al, the prior art.

The motivation for utilizing a particular deposition rate is that it allows for controlling the target life. (Column 8 lines 48-52)

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have utilized a particular deposition rate as taught by Kikukawa et al. and Ohno et al. because it allows for controlling the target life.

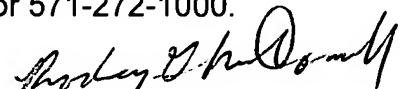
REMARKS:

deNeufville et al. is now cited to teach the composition required by the claims including the incorporation of Sn. The prosecution is reopened based on this newly cited reference. The Examiner awaits comments on the rejections.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Rodney G. McDonald whose telephone number is 571-272-1340. The examiner can normally be reached on M-TH with every Friday off..

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam X. Nguyen can be reached on 571-272-1342. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.



Rodney G. McDonald
Primary Examiner
Art Unit 1753

RM
June 7, 2007